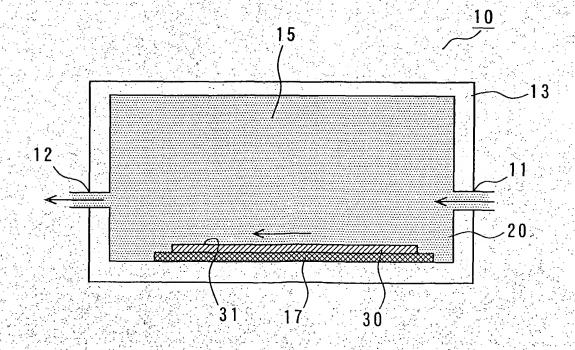
Fig. 1 62~ <u>40</u>

Fig. 2



Title: CHEMICAL PROCESSOR, CHEMICAL PROCESSING METHOD AND METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE
Inventors: NAKAMOTO et al.
Atty Docket No.: 402697
Leydig, Voit & Mayer 202-737-6770

Fig. 3

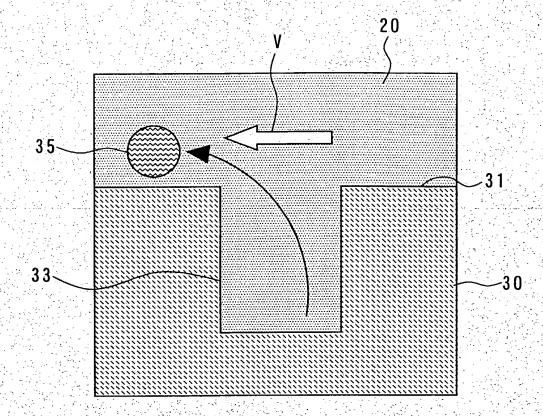
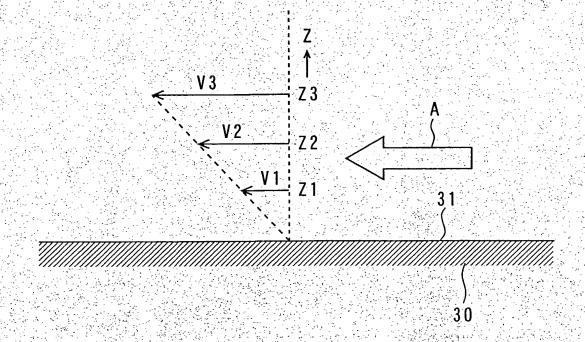


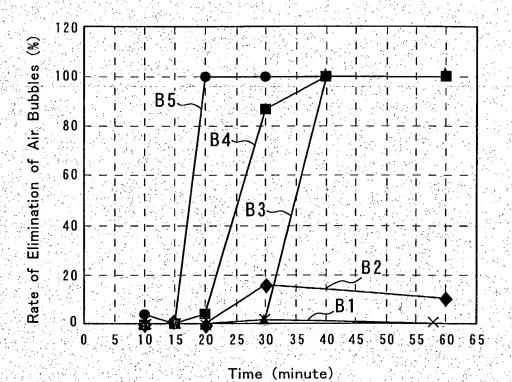
Fig. 4



Title: CHEMICAL PROCESSOR, CHEMICAL PROCESSING METHOD AND METHOD FOR MANUFACTURING

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Fig. 5



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Fig. 6

